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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ogata et al.

Art Unit: 1712

Application No.: 10/748,190

Examiner: Marc S. Zimmer

Filed: December 31, 2003

Docket: 1608-3 DIV

Confirmation No.: 5536

For: POSITIVE RESIST COMPOSITION
AND BASE MATERIAL CARRYING
LAYER OF THE POSITIVE RESIST
COMPOSITION

Dated: February 5, 2007

I hereby certify this correspondence is being deposited with
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: February 5, 2007

Signature: Marcy H. Mancuso 

AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. §1.111

Sir:

This is in response to the final Office Action mailed December 4, 2006, a reply to which is due by March 4, 2007, please amend the above-identified application as follows. As this response is being filed within two months of the mailing of the Office Action, a reply by the three month due date is respectfully requested. As February 4, 2007, fell on a Saturday, this Amendment and Response to Office Action is timely filed under the two-month rule on Monday, February 5, 2007.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.